Force characterization and analysis of thin film actuators for untethered microdevices

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Force characterization and analysis of thin film actuators for untethered microdevices

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ABSTRACT
In recent years, untethered microdevices have drawn significant attention due to their small size, weight and their ability to exert forces without the need for wires or tethers. Such microdevices are relevant to implantable biomedical devices, miniature robotics, minimally invasive surgery, and microelectromechanical systems. While devices using these actuators have been widely utilized in pick-and-place and biopsy applications, the forces exerted by these actuators have yet to be characterized and analyzed. Lack of precise force measurements and validated models impedes the clinical applicability and safety of such thin film microsurgical devices. Furthermore, present-day design of thin film microdevices for targeted applications requires an iterative trial-and-error process. In order to address these issues, we present a novel technique to measure the force output of thin film microactuators. Also, we develop and fabricate three designs of residual stress microactuators and use them to validate this technique, and establish a relationship between performance and design parameters. In particular, we find an inverse dependence of the thickness of the actuator and its force output, with 70 nm, 115 nm and 200 nm actuators exerting 7.8 µN, 4.7 µN, and 2.7 µN, respectively. Besides these findings, we anticipate that this microsystem measurement approach could be used for force measurements on alternate microactuators including shape memory, piezo and electromagnetic actuators.

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Microscale devices have the potential of revolutionizing the fields of implantable biomedical devices, miniature robotics, minimally invasive surgery, and microelectromechanical systems. In recent years, studies have shown these devices operating in hard-to-reach or constrained environments to perform a wide variety of tasks. In particular, they appear to be highly effective for applications such as targeted drug delivery, particle separation, mixing, pumping, assembly, manipulation, microsurgery, chemical analysis, and many more.1–12

Due to miniaturization requirements, these microdevices cannot use traditional wired actuators, whose on-board power sources cannot be miniaturized to the prescribed scale. In addition, parallel or swarm operations could benefit from unwired actuators that could be mass produced and respond in parallel to an environmental or external stimulus. Consequently, researchers have investigated the development of microactuators capable of wirelessly harnessing power stored within the material itself or from their surroundings.13–16

In particular, thin film microactuators are drawing significant attention for such tasks.13–19 These actuators are developed combining thin-film deposition techniques with actuation principles such as magnetostriction, inverse piezoelectricity, shape memory effect and bimetallic stress mismatches. Consequently, thin film actuators can be triggered using a variety of signals, including magnetic fields,
electric fields, or temperature changes.\textsuperscript{20,21} This actuation flexibility is combined with a number of properties, such as high power to weight ratios, ease of fabrication, wireless actuation, large transformation stresses, chemical resistance, and biocompatibility, that render thin film actuators particularly suitable for untethered microdevices for biomedical applications.

In biomedical and clinical applications, reliable microactuators would have to operate with high predictability and repeatability, in order to ensure that they do not pose any risk of damage to the manipulated material. While finite element (FE) analyses and force measurements have been previously presented for piezoelectric, electromagnetic, and shape memory microactuators, the force exerted by untethered bimetallic microactuators has yet to be measured.\textsuperscript{22–31} Consequently, microscale adaptations of macroscale models have to be used for the estimation of the force output of such actuators. However, with scale changes of several orders of magnitude, previously negligible effects can become exceptionally relevant. Clearly, FE methods do address some of these effects, nonetheless the reliability of the resulting model cannot be guaranteed until it is validated. In turn, the unreliability of such models impedes the evaluation of the clinical safety and applicability of thin film devices in microsurgical environments. Moreover, the absence of precise force estimates constrain micro-device designers to perform time-consuming trial-and-error procedures.

The reason behind this lacuna is that the measurement of forces at this scale is challenging. Not only does it require precise sensors, but also micron-precision positioning and pose reconstruction techniques. These latter techniques are indispensable to perform accurate measurements, especially for rotary actuators, for which measured forces are strictly related to the length of the arm.

In this study, we use a stereo microscopy system, a calibrated force sensor, and a closed-loop thermocontroller to develop a reliable technique to measure the force output of thin film microactuators. Further, we design and fabricate three thin film residual stress actuators, improving their modeling and design processes.

The thin film actuators presented in this work are fabricated as follows:\textsuperscript{11,15,43} first, a sacrificial layer of 15 nm Cr and 200 nm Cu is deposited by thermal evaporation to allow for later actuator lift off. Subsequently, AZ5214 photoresist based lithography is used to pattern the stress bilayer. Then, thin films of 75 nm Cr and the desired thickness of Au are deposited by thermal evaporation. SU-8 3010 is used in the photolithography procedure to create the thick rigid holder and the arm of the actuator (Fig. 1). In the next step, we pattern the thermo-sensitive trigger layer using wax molded in a 10 um thick mold of SPR220 photoresist. The structures can then be released from the substrate using a copper etchant (APS-100) to dissolve the copper sacrificial layer. Finally, the actuators are ready to be tested after being thoroughly rinsed in DI water.

The force exerted by these actuators is measured in the setup shown in Figure 2, while a detailed list of the used components is reported in Table I. Similar to previous literature, two micromanipulators are used to align the actuator and the sensor, while positioning them at a distance of 5 \( \mu m \).\textsuperscript{25} Two orthogonally-oriented cameras are used to inspect this alignment and ensure correct positioning in three dimensions.\textsuperscript{38} The calibrated nano-force sensor can then measure the contact forces as the closed-loop temperature controller triggers the actuation of the thin film actuator (Fig. 3). For this purpose, the temperature controller is regulated to reach the reference temperature of 40 \( ^\circ C \), 3 \( ^\circ C \) above the melting temperature of the wax used to constrain the microactuators. As the actuation is driven by the release of residual stress, the direction of motion of these actuators cannot be reversed.

Throughout the experiments we analyze the effect of changes in the thickness of the Au layer on the force exerted by the thin-film actuators. For this purpose, the actuators are positioned on top of a slide of hydrolytic class 1 borosilicate glass (170 \( \mu m \) thick) that is...
FIG. 2. Optical image and computer assisted rendering of the used setup. Two CCD cameras combined with zoom modules are used for orthogonal imaging of the sample. The force sensor is mounted on a vertical linear-stage and is free to move only in the z direction. The system is capable of measuring compressive forces in the range of -100 µN to 100 µN along the probe axis (red arrow), with a resolution of 100 nN. In order to minimize spurious signals a low-noise power supply is combined with an integrated voltage regulator. A temperature closed-loop control is implemented on a microcontroller. The temperature is increased using a Peltier element, while an amplified RTD sensor signal is used for feedback. Finally, an XYZ stage (not shown) is used for sample positioning with µm precision. Further details are provided in Table I.

FIG. 3. Representative microscopic images of front (right) and side (left) views of the actuators during a force measurement experiment. At the beginning of the experiment, the force actuator is positioned at less than 5 µm distance from the end of one tip of the actuator, as shown in the top images. The temperature reference is then set to 40°C. As the temperature increases the wax layer softens, allowing the release of the unconstrained stress of the bilayer. Consequently, the actuator will start folding until it comes in contact with the force sensor, providing a measurement of its force output. Not being constrained by the force sensor, the other actuators on the sample will continue to fold as shown in the bottom images. Scale bar: 500 µm.

placed on a Peltier heating element (initially at room temperature). After the sample is correctly positioned using the XYZ linear stage, the closed-loop temperature control is activated, reaching the reference temperature of 40°C in about 25 s. In turn, this temperature softens the wax layer, allowing the microactuator to release its stress. However, constrained by the force sensor, the hinge of microactuator is not able to fold, consequently exerting its force on the tip of the sensor (Fig. 3). A few minutes after the force output stabilizes, the experiment is terminated. Ten trials are performed for each of the three selected residual-stress layer thicknesses: 70 nm, 115 nm, and 200 nm (Fig. 3).

The measured data shows that the force decreases with increasing thickness of the bilayer (Table I). In particular, as the Au thickness increases from 70 nm to 115 nm, and from 115 nm to 200 nm, we notice a 39% and 43% force decrease, respectively. Here, it may

TABLE I. This table lists the components used for the assembly of the system. We refer the reader to previous publications for details regarding the design of the support structure.1

<table>
<thead>
<tr>
<th>Component</th>
<th>Model</th>
</tr>
</thead>
<tbody>
<tr>
<td>Cameras</td>
<td>Grasshopper 3 (FLIR, USA)</td>
</tr>
<tr>
<td>Optics</td>
<td>1.7-12× Zoom Module (Qioptiq, UK)</td>
</tr>
<tr>
<td>Force Sensor</td>
<td>FT-S100 (FemtoTools, Switzerland)</td>
</tr>
<tr>
<td>Power Supplier</td>
<td>SM 70-22 (Delta Electronika, Netherlands)</td>
</tr>
<tr>
<td>Heater</td>
<td>180 W Peltier Element (Farnell, Netherlands)</td>
</tr>
<tr>
<td>Temperature Sensor</td>
<td>Pt 1 kΩ RTD (RS, Netherlands)</td>
</tr>
<tr>
<td>Amplifier</td>
<td>MAX31865 (Adafruit, USA)</td>
</tr>
<tr>
<td>Microcontroller</td>
<td>Arduino Uno (Arduino, Italy)</td>
</tr>
<tr>
<td>Micromanipulators</td>
<td>XYZ stage (MISUMI, Japan)</td>
</tr>
</tbody>
</table>
be noted that the Au layer acts as a support to the active Cr film, that provides the actuating force. Thus changing the thickness of Au in the stress bilayer, by keeping the Cr thickness constant, we look only at the dependence of the force on the thickness of the bilayer. Consequently, the reduction in the force with increasing bilayer thickness can be linked to the multilayer thin film curvature model, which predicts that by changing the thickness of the passive layer, the fold-in angle is decreased due to the increased bending rigidity of the film.\(^\text{44–46}\) We hypothesize that the folding angle should have a direct correlation with the force for a fixed length of the hinge of the actuator. Moreover, we also notice differences in the behavior of the actuators. Specifically, thinner actuators exhibit a higher variability of the force output and its derivative than thicker ones (Table II).

We believe these phenomena to be due to lower structural integrity and larger variability in deposition of thinner films.

In recent years, thin film bilayer actuators have been increasingly proposed for the actuation of untethered surgical micro-robots.\(^\text{52–54}\) Therefore, it is interesting to compare the measured force to that required in surgical interventions, particularly for piercing soft tissue. However, the quantitative mechanical analyses of soft body penetration are strongly dependent on specific combinations of the perforated material, and shape and material of the perforator. Consequently, a complex ex-vivo experimental analysis would be required to exactly model such interactions. In spite of this, several studies model and measure the forces involved in the insertion of micro-needles.\(^\text{55–61}\) Assuming a similar interaction for our actuators, a pressure of about 76 kPa would be required (using porcine intestine as model). Thus a cylindrical thin film 4\(\mu\)N actuator having a tip radius smaller than 6 \(\mu\)m could penetrate such tissue. Most thin film actuators, as the ones presented here, have a contact tip that is significantly smaller, yet they do not have a circular cross-section. Therefore, further investigation is required to experimentally determine their clinical applicability based on specific designs.

Overall, in this study we develop a procedure to measure the force output of thin film micro-actuators. In particular, the experimental validation of such a technique provides the first measurement of the force of wireless bilayer thin film actuators. Moreover, the effect of film thickness is also analyzed, showing a strong relation between force and film thickness. This procedure and data analysis provide crucial tools for the design and validation of micro-devices intended to exert forces in a specific range. Finally, this work also provides a preliminary estimation of forces required for the use of micro-devices in microsurgical applications.

In the future, we will analyze the effect of other design aspects and quantify the force output of more complicated structures. Moreover, it will be interesting to see how the force estimates obtained from these measurements will translate to soft tissue puncturing experiments using stress driven actuators.

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**REFERENCES**


![FIG. 4. Plot of the force output of the thin film actuators during the experiments. The red, green, and blue curves in the main plot depict the average force output over the ten trials for thin film actuators with Au thickness of 200 nm, 115 nm, and 70 nm, respectively. The similarly-colored shaded area represents the standard deviation. Conversely, the inset shows a representative result of the individual actuators. These raw-data curves are colored in a darker shade of color, in order to distinguish the performance of a single actuator from the average results.](image-url)

**TABLE II.** Table summarizing the obtained results relating the gold layer thickness to the weight and average maximum force (over ten trials) of the thin film micro-actuators. The obtained results appear consistent with preliminary FE analyses and previous literature on thin film shape memory alloy micro-actuators of similar footprint.\(^\text{52–54}\)

<table>
<thead>
<tr>
<th>Au Thickness</th>
<th>Weight ((\mu)g)</th>
<th>Max Force ((\mu)N)</th>
</tr>
</thead>
<tbody>
<tr>
<td>70 nm</td>
<td>1.57</td>
<td>7.8 ± 1.1</td>
</tr>
<tr>
<td>115 nm</td>
<td>1.68</td>
<td>4.7 ± 0.9</td>
</tr>
<tr>
<td>200 nm</td>
<td>1.78</td>
<td>2.7 ± 0.4</td>
</tr>
</tbody>
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